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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akifumi KAMIJIMA et al.

Application No.: 09/966,080

Filed: October 1, 2001

Group Art Unit: 1756

Examiner: J. Ruggles

Docket No.: 110735

For: A METHOD FOR FABRICATING A RESIST PATTERN, A METHOD FOR PATTERNING A THIN FILM AND A METHOD FOR MANUFACTURING A MICRO DEVICE

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 26, 2003 Office Action, please consider the following:

**Amendments to the Claims** are reflected in the listing of claims;

**Amendments to the Drawings** include attached replacement sheets; and

**Remarks.**

RECEIVED  
JUN 30 2003  
GROUP 1700